

**Notice of References Cited**

Application/Control No.

10/593,904

Applicant(s)/Patent Under  
Reexamination  
MAEDE ET AL.

Examiner

David Hung Vu

Art Unit

2821

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,205,967	04-2007	Morishige et al.	345/77
*	B	US-7,170,479	01-2007	Kimura, Hajime	345/82
	C	US-			
	D	US-			
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	F	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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